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> > February 10, 1992

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GROUP 250

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Honorable Commissioner of Patents and Trademarks Washington, D.C. 20231

Re:

Attention: Examiner S. Loke

Group Art Unit 288

IR-1013 (Cont) (2-563) OFGS File: Affiliation SN 653,017

PLURAL POLYGON SOURCE PATTERN FOR MOSFET

Dear Mr. Loke:

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As discussed by telephone today, attached is a copy of amended Figs. 1, 3, 4 and 5 which were referred to at page 2 of the Preliminary Amendment.

In Fig. 1, numeral 83 (at the bottom of the sheet) is changed to 82.

In the sheet containing Figs. 2 and 3, Fig. 3, the location of the section line is dropped slightly.

In the sheet containing Figs. 4 and 5, numerals 31 and 32 are added. No change is made to Fig. 5.

Respectfully submitted,

OSTROLENK, FABER, GERB & SOFFEN

Samuel H. Weiner

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